

PATENT APPLICATION  
IN THE U.S. PATENT AND TRADEMARK OFFICE  
January 22, 2004

Applicants: Shinji SETO et al

For: OSCILLATION PREVENTION CIRCUIT

Serial No.: 10/008 875

Group: 2681

Confirmation No.: 5314

Filed: November 8, 2001

Examiner: Unknown

Atty. Docket No.: Sada Case 794

Commissioner for Patents  
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Alexandria, VA 22313-1450

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INFORMATION DISCLOSURE STATEMENT

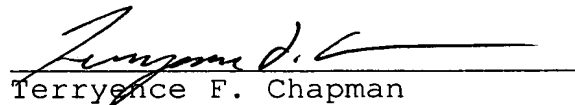
Sir:

In compliance with the provisions of Rules 97(e)(1) and 1.98, enclosed herewith is a copy of the European Patent Office Search Report, Form PTO-1449 and the references cited thereon. The relevance of these references is explained on the enclosed search report. Accordingly, further comment at this point in time should not be necessary.

I hereby certify that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Further consideration is respectfully solicited.

Respectfully submitted,

  
Terryence F. Chapman

TFC/smd

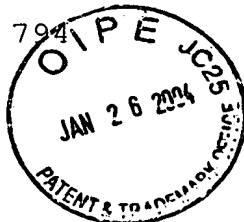
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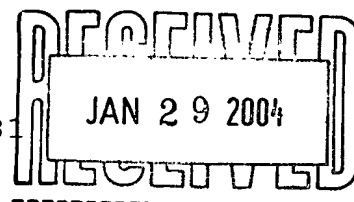
Encl: Copy of European Patent Office Search Report  
dated October 23, 2003 (5 pages)  
Form PTO-1449 and references cited thereon  
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Correspondence: Information Disclosure Statement  
dated January 22, 2004  
including enclosures listed thereon

190.05/03

INFORMATION DISCLOSURE CITATION	Applicant: Shinji SETO et al
	Ser.No. : 10/008 875      Filed : November 8, 2001
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	Group : 2681

U.S. PATENT DOCUMENTS							
Examiner Initial*	Document Number	Date	Name	Class	Sub Class	Filing Date	
	AA	4 049 911	9/1977	SCHLAFF et al			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS								
	Document Number	Date	Country	Class	Sub Class	Translation Yes No		
	AL	FR 2 755 561	5/1998	France				X
	AM	EP 0 486 990	5/1992	Europe				
	AN							
	AO							
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OTHER DOCUMENTS (Including Author, Title, Date, Pages, Etc.)	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.